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PATENT

In the United States Patent and Trademark Office

Applicant: John E. Lang

Applicant's Ref: LAM2P266

Application No: 09/274,194

Filed: March 22, 1999

Title: METHOD OF REMOVING PHOTORESIST  
MATERIAL WITH DIMETHYL SULFOXIDE

Examiner: C. Brown

Group Art Unit: 1765

Date: August 6, 2001

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on August 6, 2001.

Signed: \_\_\_\_\_

Kay Harlow

Separate Letter to the Official Draftsperson

Commissioner for Patents  
Box Official Draftsperson  
Washington, D.C. 20231

Dear Sir:

Enclosed herewith are the formal drawings (Figures 1, 2, 3 and 4), for the above-referenced case. If the draftsperson has any questions concerning these drawings, please contact the undersigned at the number set forth below. If any fees are due in connection with the filing of these drawings, please charge such fees to deposit account 50-0805 (Order No. LAM2P266).

Respectfully submitted,  
MARTINE & PENILLA, LLP

Albert S. Penilla, Esq.  
Reg. 39,487

710 Lakeway Drive, Suite 170  
Sunnyvale, CA 94085  
(408) 749-6900  
Customer Number 25920

Attorney Docket No: LAM2P266

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